



1763 *Stev*

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Blees	Examiner:	Kackar, R.
Serial No.:	09/759,179	Group Art Unit:	1763
Filed:	January 12, 2001	Docket No.:	NL 000044 (VLSI.415PA)
Title:	Stamp For Use In A Lithographic Process, Method Of Manufacturing A Stamp, And Method Of Manufacturing A Patterned Layer On A Substrate		

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence and the papers, as described hereinabove, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on August 24, 2004.

By: *Erin M. Nichols*
Erin M. Nichols

OFFICE ACTION RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the non-final Office Action dated June 4, 2004, please consider the following amendment and remarks.

Amendments to the claims are reflected in the listing of claims beginning at page 2 and the Remarks begin on page 5.